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10/659,748	09/11/2003 RULE	438	2894	031140
APPLICANTS Manabu Nakamura, Aizuwakamatsu, JAPAN; Hiroyuki Nansei, Aizuwakamatsu, JAPAN; Kentaro Sera, Aizuwakamatsu, JAPAN; Masahiko Higashi, Aizuwakamatsu, JAPAN; Yukihiro Utsuno, Aizuwakamatsu, JAPAN; Hideo Takagi, Aizuwakamatsu, JAPAN; Tatsuya Kajita, Aizuwakamatsu, JAPAN;				
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** FOREIGN APPLICATIONS ***** JAPAN 2002-273625 09/19/2002				
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 12/03/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/BRADLEY SMITH/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 8	TOTAL CLAIMS 18
INDEPENDENT CLAIMS 1				
ADDRESS WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP 1250 CONNECTICUT AVENUE, NW SUITE 700 WASHINGTON, DC 20036 UNITED STATES				
TITLE Method of manufacturing semiconductor device having gate or tunnel insulation film				
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees		
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